

Our Docket No: 42P10058D

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)		
	)		
Han-Ming Wu et al.	)	Examiner:	Not yet assigned
	)		
Serial No: Not yet assigned	)	Art Unit:	Not yet assigned
	)		
Filed: Concurrently Herewith	)		
	)		
For: Purging Gas from a	)		
Photolithography Enclosure	)		
Between a Mask Protective	)		
Device and a Pattern Mask	)		
	)		
A Rule 1.53(b) Divisional Application of	)	Examiner:	Hung Nguyen
Serial No.: 09/752,938	)	Art Unit:	2851
Filed: Dec. 29, 2000	)		

PRELIMINARY AMENDMENTS

Mail Stop Divisional Patent Applications  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the present Rule 1.53(b) divisional application, please enter the following amendments and consider the following remarks.

EXPRESS MAIL CERTIFICATE OF MAILING

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Date of Deposit: January 16, 2004

I hereby certify that I am causing this paper or fee to be deposited with the United States Postal Service "Express Mail Post Office to Addressee" service on the date indicated above and that this paper or fee has been addressed to the Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Krista Mathieson

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January 16, 2004

(Date signed)